

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
Stylesheet Version v1.2

EPAS ID: PAT4673448

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
XUGUANG JIANG	10/06/2017
YONG ZHANG	10/10/2017
YIWU DING	10/10/2017
RECEIVING PARTY DATA	
Name:	KLA-TENCOR CORPORATION
Street Address:	ONE TECHNOLOGY DRIVE
City:	MILPITAS
State/Country:	CALIFORNIA
Postal Code:	95035
PROPERTY NUMBERS Total: 2	
Property Type	Number
Application Number:	15803091
Application Number:	62549775
CORRESPONDENCE DATA	
Fax Number:	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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Email:	ipdocketing@hodgsonruss.com
Correspondent Name:	KLA-TENCOR CORPORATION / HODGSON RUSS LL
Address Line 1:	THE GUARANTY BUILDING
Address Line 2:	140 PEARL STREET, SUITE 100
Address Line 4:	BUFFALO, NEW YORK 14202-4040
ATTORNEY DOCKET NUMBER:	078697.00086 (P5079)
NAME OF SUBMITTER:	NATHANIEL LUCEK
SIGNATURE:	/nathaniel lucek 60766/
DATE SIGNED:	11/03/2017
Total Attachments: 2	
source=P5079_assignment#page1.tif	
source=P5079_assignment#page2.tif	

ASSIGNMENT

In consideration of One Dollar (\$1.00), and other good and valuable consideration, the receipt of which is hereby acknowledged, **Xuguang Jiang**, residing at 750 Brahms Way, Apt. 16, Sunnyvale, California 94087; **Yong Zhang**, residing at 20781 Cheryl Drive, Cupertino, California 95014; and **Yiwu Ding**, residing at 1639 Fountain Springs Circle, Danville, California 94526, the undersigned

Hereby sell, assign, and transfer to KLA-Tencor Corporation, having a place of business at One Technology Drive, Milpitas, California 95035, its successors, assigns, and legal representatives, the entire right, title, and interest for the United States and all foreign countries, in and to any and all inventions disclosed in the following patent applications:

Country	Patent Application No.	Filing Date	Title
US	62/549,775	August 24, 2017	Local Reference Algorithm (LRA) for transparent and translucent wafer defect detection on Altair tool

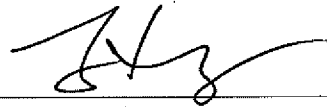
And in and to said applications and all applications that claim priority to any of the aforementioned applications including all divisional, continuation, reissue, and continuation-in-part applications, or national or regional phase applications thereof, which have been or shall be filed in the United States and all foreign countries on any of said inventions; all rights of priority to any of the aforementioned applications; and in and to all original and reissued patents which have been or shall be issued in the United States and all foreign countries on said inventions;

Agree that said Assignee may apply for and receive Patents for said inventions in its own name; and agree that, when requested, shall execute all rightful oaths or declarations, assignments, powers of attorney, and other papers and generally do everything possible which said Assignee, its successors, assigns, or representatives shall consider desirable for aiding in securing, maintaining, and enforcing proper patent protection for said inventions; and

Assignment to P5079

Covenant with said Assignee, its successors, assigns, and legal representatives that no assignment, grant, mortgage, license, or other agreement affecting the rights and property herein conveyed has been made to others by the undersigned, and that full right to convey the same as herein expressed is possessed by the undersigned.

Date: 10/6/17



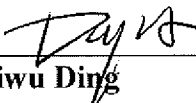
Xuguang Jiang

Date: 10/10/17



Yong Zhang

Date: 10/10/17



Yiwu Ding

For KLA-Tencor Corporation:

Date: _____

Signature

Name

Title